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		Applicant Toshiyuki KAWAGUCHI et al.				
		Filing Date		Group Art Unit		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation Yes No
/GH/	09-035927	02-1997	Japan			Abstract
↓	2001-053487	02-2001	Japan			Abstract
	09-115708	05-1997	Japan			Abstract
	2001-308574	11-2001	Japan			Abstract
	2003-115692	04-2003	Japan			Abstract
↓	11-354972	12-1999	Japan			Abstract
/GH/	05-183285	07-1993	Japan			Abstract
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
/G.H./	Masaki ABE et al., "Application of Thin Ferrite Film and Ultra-Fine Particles formed in Aqueous Solution to Microwave/Nano-Biotechnology", p721-729, No. 6, Vol. 27, 2003; Journal of The Magnetics Society of Japan					
/G.H./	International Search Report PCT/JP2004/002104 filed April 27, 2004					
Examiner /Gary Harris/		Date Considered 05/11/2007				
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /G.H./